

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	TOMINAGA KOJI ET AL.	)	
Serial No.:	10/550,805	)	Group Art Unit: 2813
Filed:	July 12, 2006	)	Examiner: Luke, Daniel M.
For:	METHOD FOR FORMING AN	)	Confirmation No. 3990
	INSULATING FILM IN A	)	
	SEMICONDUCTOR DEVICE	)	

**VIA EFS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION**

Sir:

This amendment is respectfully submitted in response to the Final Office Action dated April 30, 2008. Applicants hereby respectfully petition for a one-month extension of time. If there are any charges with respect to this Amendment or otherwise, please charge them to Deposit Account No. 06-1130 maintained by Applicants' attorneys.

Please amend the Application as follows: